Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Currently Amended) An ink jet recording apparatus comprising a plurality of nozzles for discharging a functional liquid,

wherein said plurality of nozzles is divided into a plurality of groups the number of which is fewer than the number of said nozzles, wherein each group contains nozzles located next to each other, and

wherein discharge quantity and flight speed of said functional liquid discharged from said nozzles is regulated for each group by voltage level applied to piezoelectric elements corresponding to said nozzles.

- 2. (Previously Amended) The ink jet recording apparatus according to claim 1, wherein said functional liquid is ink that is usable to manufacture a color filter.
- 3. (Previously Amended) The ink jet recording apparatus according to claim 1, wherein said functional liquid is a solution of electroluminophor that is usable to manufacture an EL element substrate.
- 4. (Previously Amended) The ink jet recording apparatus according to claim 1, wherein said functional liquid is an electrically conducting particle dispersion solution that is usable to manufacture a substrate comprising a conducting wiring pattern.
- 5. (Previously Amended) The ink jet recording apparatus according to claim 1, wherein positions on ink jet head on which said plurality of nozzles is arranged are divided into a plurality of areas, and nozzles belonging to each area are made to belong to a single group.
 - 6. (Previously Amended) The ink jet recording apparatus according to claim 1,



wherein said ink jet head on which said plurality of nozzles is arranged comprises cavities provided for each of said nozzles, a reservoir communicating to said cavities and common to said nozzles, and a supply port for supplying said functional liquid to said reservoir; and

wherein said plurality of groups comprise at least a first group comprising nozzles of said plurality of nozzles positioned close to said supply port, and a second group comprising nozzles of said plurality of nozzles positioned far from said supply port.

7. (Currently Amended) A method for manufacturing a functional liquid applied substrate by an ink jet recording apparatus that has a plurality of nozzles capable of discharging a functional liquid,

said plurality of nozzles is divided into a plurality of groups the number of which is fewer than number of said nozzles, each group contains nozzles located next to each other, comprising the steps of:

regulating, for each group, waveform of a signal-voltage level applied to

piezoelectric elements corresponding to said nozzles for controlling discharge quantity and

flight speed of said functional liquid from said nozzles, and

discharging said functional liquid into pixels formed on a substrate.

- 8. (Original) The method for manufacturing a functional liquid applied substrate according to claim 7, wherein positions on ink jet head on which said plurality of nozzles is arranged are divided into a plurality of areas, and nozzles belonging to each area are made to belong to a single group.
- 9. (Previously Amended) The method for manufacturing a functional liquid applied substrate according to claim 7,

wherein said ink jet head on which said plurality of nozzles is arranged comprises cavities provided for each of said nozzles, a reservoir communicating to said





cavities and common to said nozzles, and a supply port for supplying said functional liquid to said reservoir; and

wherein said plurality of groups comprise at least a first group comprising nozzles of said plurality of nozzles positioned close to said supply port, and a second group comprising nozzles of said plurality of nozzles positioned far from said supply port.

- 10. (Previously Amended) A method for manufacturing a device comprising a functional liquid applied substrate manufactured by the method according to claim 7.
- 11. (Original) A method for manufacturing electronic equipment wherein an electro-optical apparatus manufactured by the method according to claim 10 is used.
- 12. (Previously Amended) A device comprising a functional liquid applied substrate manufactured by the method according to claim 7.